

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 11, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG799685562

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

6.43 - 6.47 X 3.91 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.00 CARAT

E

VVS 2

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

NONE

IGI LG799685562

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS

Medium To Slightly Thick (Faceted)

61%

33.4°

41.4°

60.6%

44%

13%

Pointed

CLARITY CHARACTERISTICS

KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

Sample Image Used

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

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Girdle

Culet

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